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UNITED STATES PATENT & TRADEMARK OFFICE

Examiner: Unknown

Art Unit: Unknown

Applicant:

LEE, Choul-Gyun, et al.

Serial No.:

To be assigned

Filed

Herewith

For:

**MULTI-LAYERED
PHOTOBIOREACTOR AND METHOD
OF CULTURING PHOTOSYNTHETIC
MICROORGANISMS USING THE
SAME****INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 17, 2005

Sir:

Pursuant to M.P.E.P. §609 and 37 C.F.R. §§1.56, 1.97-1.99, Applicants herewith submit form PTO-1449 (1 sheet), which lists references cited in the International Search Report (ISR) dated October 1, 2004 and of which Applicants are aware for the present application. A copy of the ISR is attached hereto. It is noted that the Applicants have not enclosed a copy of the U.S. patents cited on form PTO-1449. Copies of the remaining references have not been enclosed because it is believed that they will be submitted to the USPTO via the IPEA. It is nonetheless noted that each has been designated as an "A" type reference. A copy of each will be provided upon request.

This submission does not represent that a search has been made or that no better art exists. While the term "references" is used in citing the documents called to the Examiner's attention herein, Applicants do not make any admission that each or all of them are "prior art" references within the meaning of the statutory and case law.

JGOC Rec'd PCT/PTO 17 MAY 2005

Applicants reserve the right to contend, where appropriate, that a patent asserted against any claim of the present application is not prior art under the facts and the law.

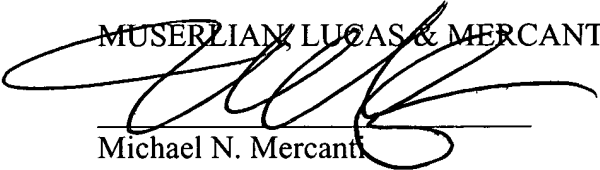
Applicants also reserve the right to present appropriate arguments and/or evidence to establish patentability over the references, should one or more of the references be applied against the claims of the present application.

Applicants request that the Examiner independently determine those items which the Examiner would consider the most pertinent of all the references cited herein.

This Information Disclosure Statement is filed with the application and is therefore within three (3) months of the filing date of this application. Accordingly, this document complies with the requirements of 37 C.F.R. Section 1.97(b). It is respectfully requested that the references cited in the accompanying PTO-1449 form be considered and made of record.

Respectfully submitted,

MUSERLIAN, LUCAS & MERCANTI, LLP

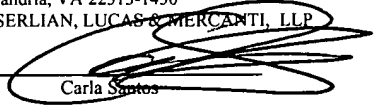

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MUSERLIAN, LUCAS & MERCANTI, LLP

By: 
Carla Santos

JC06 Rec'd PCT/PTO 17 MAY 2005
 Application Number 10/535386
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INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)
 428.1052

Applicant(s)
 LEE, Choul-Gyun, et al.

Filing Date
 Herewith

Group Art Unit
 Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A1	5,882,849	03/16/1999	Leonard, et al.			07/01/1996
	A2	6,022,701	02/08/2000	Boussiba, et al.			01/30/1997

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.